

10/561833

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Teulet
Appl. No. :
Filed : December 22, 2005
Title : DEVICE FOR THE PRODUCTION OF THIN POWDER LAYERS, IN PARTICULAR AT HIGH TEMPERATURES, DURING A METHOD INVOLVING THE USE OF A LASER ON A MATERIAL
Grp./A.U. :
Examiner :
Docket No.: 15279NP

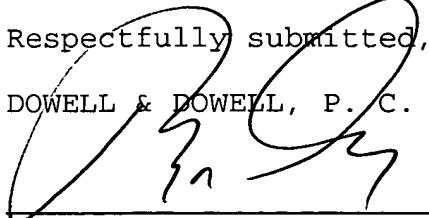
Honorable Commissioner of Patents
Alexandria, VA 22313-1450
Sir:

PTO CUSTOMER NO. 000293

INFORMATION DISCLOSURE STATEMENT

In accordance with 37 C.F.R., §§ 1.97-1.99, applicant submits the following information which may be of interest to the examiner in charge of the above referenced application for patent. Copies of the references listed on the attached form are not being submitted as the International Search Report was prepared by the European Patent Office, therefore, copies should have been received by the US Patent Office from the European Patent Office.

Also being submitted herewith is a copy of the International Search Report with respect to PCT/FR2004/001646 which list the relevance of the listed patents.

Respectfully submitted,
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Date: December 22, 2005

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(Rev. 7-80)U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

Atty. Docket No. 15279NP

Serial No. 0501833

LIST OF PRIOR ART CITED BY APPLICANT
(Use several sheets if necessary)

APPLICANT Teulet

FILING DATE 12/24/05

GROUP

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA	5 252 264	10/12/93	Forderhase			
	AB	5 876 550	3/2/99	Feygin			
	AC	6 391 251	5/21/02	Bullen			
	AD	US 2003 059492 A1	3/27/03	Gaillard			
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
	AL	FR 2 774 931	8/20/99	France			Corresponding US	6767499
	AM							
	AN							
	AO							
	AP							

OTHER PRIOR ART (including Author, Title, Date, Pertinent Pages, Etc.)

AR			
AT			

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 602; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.